

<b>Notice of References Cited</b>	Application/Control No. 10/760,986		Applicant(s)/Patent Under Reexamination KLEIN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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X	B	US-2004/0146718	07-2004	Konrad et al.	428/424.4
X	C	US-2004/0146725	07-2004	Konrad et al.	428/475.2
X	D	US-2003/0124365	07-2003	Posey et al.	428/480
X	E	US-2004/0146750	07-2004	Klein et al.	428/694.0SG
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
X	N	WO 03/041955	05-2003	WO	Posey et al.	
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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